

APPLICATION DATA SHEET

Application Information

Application Number:: Not yet assigned
Filing Date:: Herewith
Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R?::
Number of CD Disks::
Number of Copies of CDs::
Sequence Submission?::
Computer Readable Form (CRF)?::
Number of Copies of CRF::
Title:: CONTROL OF PLASMA TRANSITIONS IN
SPUTTER PROCESSING SYSTEMS
Attorney Docket Number:: ASX-064
Request for Early Publication?::
Request for Non-Publication?::
Suggested Drawing Figure::
Total Drawing Sheets:: 10
Small Entity?:: No
Licensed US Govt. Agency::
Contract or Grant Numbers::
Secrecy Order in Parent Appl.?::

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: US
Status:: Full Capacity
Given Name:: Jeff
Middle Name:: C.
Family Name:: Sellers
Name Suffix::

City of Residence:: Manchaca
State or Province of Residence:: TX
Country of Residence:: US
Street of Mailing Address:: 2802 Chaparral Road
City of Mailing Address:: Manchaca
State or Province of Mailing Address:: TX
Country of Mailing Address:: US
Postal or Zip Code of Mailing Address:: 78652

Correspondence Information

Correspondence Customer Number:: 021323

Representative Information

Representative Customer Number:: 021323

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application		0#/###,###	MM/DD/YY

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
		MM/DD/YY	

Assignee Information

Assignee Name:: ENI Technology, Inc.
City of Mailing Address:: Rochester
State or Province of Mailing Address:: NY
Country of Mailing Address:: US